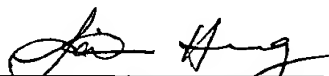




1744

In re application of: SZETSEN STEVEN LEE et al.  
Application No.: 09/849,136  
Filed: May 04, 2001  
For: HIGH EFFICIENCY SCRUBBER FOR WASTE  
GAS ABATEMENT  
Examiner:  
Art Unit:

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September 20, 2001  
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Jiawei Huang, Reg. No. 43,330

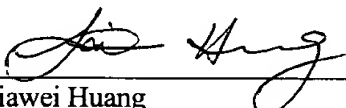
ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

Sir:

Transmitted herewith is a certified copy of Taiwan Application No. 90106865 filed on **March 23, 2001**.

A return prepaid postcard and a Request for Changing Correspondence address are also included herewith.

It is believed no fee is due. However, the Commissioner is authorized to charge any fees required, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 50-0710 (Order No. JCLA7097). A duplicate copy of this sheet is enclosed.

  
Jiawei Huang  
Registration No. 43,330

Please send future correspondence to:  
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